## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:	)	
	:	Examiner: S. A. Fraser
Takako YAMAGUCHI et al.	)	
	:	Group Art Unit: 1795
Application No.: 10/529,908	)	
	:	Confirmation No.: 5277
35 U.S.C. § 371(c)	)	
Completion Date: December 16, 2005	:	
	)	
For: METHOD OF DETECTING RELATIVE	:	October 9, 2008
POSITION OF EXPOSRE MASK AND OBJE		
TO BE EXPOSED, ALIGNMENT METHOD,	:	
AND EXPOSURE METHOD USING THE	)	
SAME	:	

## Mail Stop Amendment

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

## AMENDMENT & SUBMISSION OF SUBSTITUTE SPECIFICATION

Sir:

In response to the Official Action dated July 9, 2008, please amend the above-identified application as follows: